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Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT Date Submitted: August 8, 2006 <i>(use as many sheets as necessary)</i>		Complete If Known	
		Application Number Filing Date First Named Inventor Group Art Unit Examiner Name Attorney Docket Number	Unassigned 02/02/2006 Tadahiro OHMI Unassigned Unassigned 039262-0156
Sheet	1	of	1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	A1	2006/0263487	A1	TSUCHIYA	12-01-2005	2005 02634 97
	A2	6,204,193	B1	JOZAKI	03-20-2001	

UNPUBLISHED U.S. PATENT APPLICATION DOCUMENTS						
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FOREIGN PATENT DOCUMENTS								
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		Office ³	Number ⁴	Kind Code ⁵ (if known)				
	A3	JP	2003-347281	A	SEMICONDUCTOR LEADING EDGE TEC.	12-05-2003		A
	A4	JP	2003-533042	A	TOKYO ELECTRON LTD.	11-05-2003		A
	A5	JP	2003-188155	A	TEXAS INSTRUMENTS	07-04-2003		A
	A6	JP	11-307512		SONY CORP.	11-05-1999		A
	A7	EP	1 308 994	A1	TEXAS INSTRUMENTS	05-07-2003		

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶	
	A8	R. KAIHARA et al., "Damage-Free Contact Etching Using Balanced Electron Drift Magnetron Etcher," The Ninth International Symposium on Semiconductor Manufacturing, Proceeding of ISSM 2000, pp. 102-103.		

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.E./

Examiner Signature	/Caridad Everhart/	Date Considered	04/08/2008
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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